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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/234,233	01/20/1999	WEIMIN LI	MI22-1035	6381
21567	7590	10/07/2004	EXAMINER	
WELLS ST. JOHN P.S. 601 W. FIRST AVENUE, SUITE 1300 SPOKANE, WA 99201				VU, DAVID
ART UNIT		PAPER NUMBER		
2818				

DATE MAILED: 10/07/2004

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EXAMINER

ART UNIT      PAPER

45

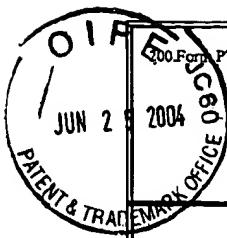
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Commissioner for Patents

Attached is a copy of the IDS dated 06/25/04 which has been considered by the examiner:

  
David Helms  
Supervisory Patent Examiner  
Technology Center 2800



GPO:2000:GPO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-1035SERIAL NO.  
09/234,233LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Weimin LiFILING DATE  
January 20, 1999GROUP  
2818

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
DV	AA	4,971,635	11-90	Stefano et al.			
	AB	6,498,084B2	12-02	Bergemont			
	AC	5,036,363	07-91	Mori			
	AD	6,638,875	10/03	Han et al			
	AE	6,720,247	04/04	Kirkpatrick et al			
	AF	6,723,631	04/04	Noguchi et al			
	AG	6,627,535	09/03	MacNeil et al			
	AH	5,593,741	01/97	Ikeda			
	AI	2003/0077916	04/03	Xu et al			
	AJ	2003/0207594	11/03	Catabay et al			
DV	AK	2004/0071878	04/04	Schuhmacher et al			

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
DV	AL 08-045926A	2/96	Japan				
	AM JP8051058	02/96	Japan				
	AN JP63316476	12/88	Japan				
DV	AO JP8078322	03/96	Japan				

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

DV	AP		Wolf, S., Silicon Process., Vol 3 pg. 635				
	AQ						
	AR						

EXAMINER

*Shulan Li*

DATE CONSIDERED

09/29/04

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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